

<b>Notice of References Cited</b>	Application/Control No. 10/500,511	Applicant(s)/Patent Under Reexamination BADYLAK ET AL.	
	Examiner Shin-Lin Chen	Art Unit 1632	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	D	US-			
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	K	US-			
	L	US-			
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**NON-PATENT DOCUMENTS**

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